Notice of References Cited Application/Control No. O9/975,801 Applicant(s)/Patent Under Reexamination AGRAWAL ET AL. Examiner Jung Park Art Unit Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	Α	US-6,788,660	09-2004	Agrawal et al.	370/331
	В	US-2002/0191560	12-2002	Chen et al.	370/331
	С	US-2002/0193116	12-2002	Agrawal et al.	455/445
	D	US-2002/0191561	12-2002	Chen et al.	370/331
	Е	US-2002/0191558	12-2002	Agrawal et al.	370/329
	F	US-5,159,592	10-1992	Perkins, Charles E.	370/338
	G	US-5,519,706	05-1996	Bantz et al.	455/435.2
	Н	US-			
	1	US-			
	J	US-			
	К	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
1	N					,
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	Р					
	Q					
	R	,			•	
	s					
	Т					·

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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	w	
	х	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)

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